

#2 7/3/01

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PTO-1449	Application No. Unknown	Applicant(s) Schimert, et al.	
	Docket Number 004578.1104	Group Art Unit Unknown	Filing Date 04/25/2001

**Information Disclosure Citation
in an Application**

U.S. PATENT DOCUMENTS

		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
T.M.	A	5,455,421	10/03/95	Spears			
T.M.	B	5,539,206	07/23/96	Schimert			
T.M.	C	5,760,398	06/02/98	Blackwell, et al.			
T.M.	D	5,945,673	08/31/99	Beratan, et al.			
T.M.	E	6,100,525	08/08/00	Eden			
T.M.	F	6,111,254	08/29/00	Eden			
T.M.	G	6,114,696	09/05/00	Eden			
T.M.	H	6,114,697	09/05/00	Eden, et al.			
T.M.	I	6,133,570	10/17/00	Schimert, et al.			
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	N						
	O						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	P							
	Q							
	R							

NON-PATENT DOCUMENTS

		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	DATE
T.M.	S	Tissot, et al., "LETI/LIR's Amorphous Silicon Uncooled Microbolometer Development", SPIE Vol. 3379, Part of the SPIE Conference on Infrared Detectors and Focal Plane Arrays V, Orlando, Florida, April 1998, pp. 139-144.	
	T		
	U		

EXAMINER

Tim Moran

DATE CONSIDERED

7-9-02

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

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